PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
GUANGLI YANG	09/29/2015
XIANYONG PU	09/29/2015
LI LIU	09/29/2015
CHIHCHUNG TAI	09/29/2015
GANGNING WANG	09/29/2015
HONG SUN	09/29/2015

RECEIVING PARTY DATA

Name:	Semiconductor Manufacturing International (Shanghai) Corporation	
Street Address:	18 Zhang Jiang Road, Pudong New Area	
City:	Shanghai	
State/Country:	CHINA	
Postal Code:	201203	

PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	15438204	

CORRESPONDENCE DATA

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Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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KILPATRICK TOWNSEND AND STOCKTON LLP **Correspondent Name:** Address Line 1: TWO EMBARCADERO CENTER, EIGHTH FLOOR

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ATTORNEY DOCKET NUMBER:	087720-039510US-1039627
NAME OF SUBMITTER:	KIEN DU PHUNG
SIGNATURE:	/Kien Du Phung/
DATE SIGNED:	02/23/2017

Total Attachments: 3

PATENT REEL: 041358 FRAME: 0301

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Attorney Docket No.: 087720-039500US-0917854 Client's Ref. No.: 2014-01404-SH-US

ASSIGNMENT

(Patent Application)

We, the undersigned, have invented certain inventions and improvements disclosed in a utility (provisional or non-provisional) or design patent application entitled

"DEVICE ISOLATION STRUCTURE AND MANUFACTURE METHOD,"

the specification of which is provided with this Assignment and identified by the Attorney Docket No. above.

For one dollar (\$1.00) and other good and valuable consideration, the receipt and sufficiency of which we acknowledge, we:

- 1. Agree to assign, transfer, convey, and sell, hereby assign, transfer, convey, and sell and have assigned, transferred, conveyed, and sold to **Semiconductor Manufacturing International (Shanghai) Corporation**, a corporation of the People's Republic of China, having a principal place of business at, 18 Zhang Jiang Road, Pudong New Area, Shanghai, People's Republic of China 201203 ("Assignee"), the entire right, title, and interest in and to:
 - (a) all intellectual property (including, without limitation, any innovation, information, invention, discovery, product, process, work or design) disclosed, embodied, shown, or claimed in the above-referenced patent application, implicitly or explicitly;
 - (b) the above-referenced patent application, the right to claim priority to the above-referenced patent application, all applications based in whole or in part upon the above-referenced patent application, including, without limitation, all applications that are a provisional, non-provisional, design, divisional, continuation, continuation-in-part, registration, utility model, industrial design, reissue, renewal, substitute, extension, reexamination, post-grant review, inter partes review, supplemental examination or non-U.S. patent application or application for other rights based in whole or in part on the above-referenced patent application;
 - (c) all patents (including, without limitation, all U.S. and non-U.S. patents, registrations, utility models, industrial designs, design patents, counterparts, continuations, continuations-in-part, divisionals, reissues, renewals, substitutes, extensions, reexaminations, post-grant reviews, inter partes reviews and supplemental examinations) that are granted or issued upon, or that claim priority to, any and all applications described in (b) of

ASSIGNMENT

DEVICE ISOLATION STRUCTURE AND MANUFACTURE METHOD

Attorney Docket No. 087720-039500US-0917854 Page 2 of 3

this paragraph or that disclose or claim intellectual property described in (a) of this paragraph, in whole or in part; and

- (d) all claims for damages by reason of past infringement of any rights under the applications or patents described in (a), (b) or (c) of this paragraph (including provisional rights to reasonable royalties pursuant to 35 U.S.C. §154(d)) and the right to sue for and collect such damages and royalties for Assignee's own use.
- 2. Authorize and request the U.S. Patent and Trademark Office or any other U.S. or non-U.S. agency to issue to the Assignee any and all patent(s), or other rights or documents, resulting from the intellectual property, patent application(s) and patents described in paragraph 1 of this Assignment.
- 3. Agree to sign all papers and documents, including without limitation, applications, declarations, oaths and petitions, and, at the Assignee's expense, perform any other acts that are necessary in connection with prosecution of patent application(s) or intellectual property described in paragraph 1 of this Assignment and the enforcement of patent(s) or other rights resulting from such patent application(s) or intellectual property.
- 4. Agree that the terms, covenants, and conditions of this Assignment shall inure to the benefit of the Assignee, its successors, assigns and other legal representative, and shall be binding upon us, as well as our heirs, legal representatives, and assigns.
- 5. Promise and affirm that we have not entered, and will not enter, into any assignment, contract, or understanding that conflicts with this Assignment.
- 6. Authorize Kilpatrick Townsend & Stockton to insert above the application number and filing date of the above-described patent application when known.

Signed on the dates indicated beside our signatures.

ASSIGNMENT

DEVICE ISOLATION STRUCTURE AND MANUFACTURE METHOD

Attorney Docket No. 087720-039500US-0917854 Page 3 of 3

Signature:	Guarna Li Yana	Date:	2015.929
	GUANGLI YANG		

Signature: VIONYONG DJ Date: 2015.9,29

Date: 2013. 9. 2

Signature: OF AND Date: VOIT 9 29

Signature: Date: 2015. 9. 29

CHIHCHUNG TAI

Signature: $\pm R \sqrt{7}$ Date: $\partial d 5/09/29$

GANGNING WANG

Date: $\frac{\partial \sigma}{\partial \sigma} = \frac{\partial \sigma}{\partial$

Signature: $\frac{3}{1}$ $\frac{3}{1}$ Date: $\frac{3}{1}$

HONG SUN

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RECORDED: 02/23/2017